

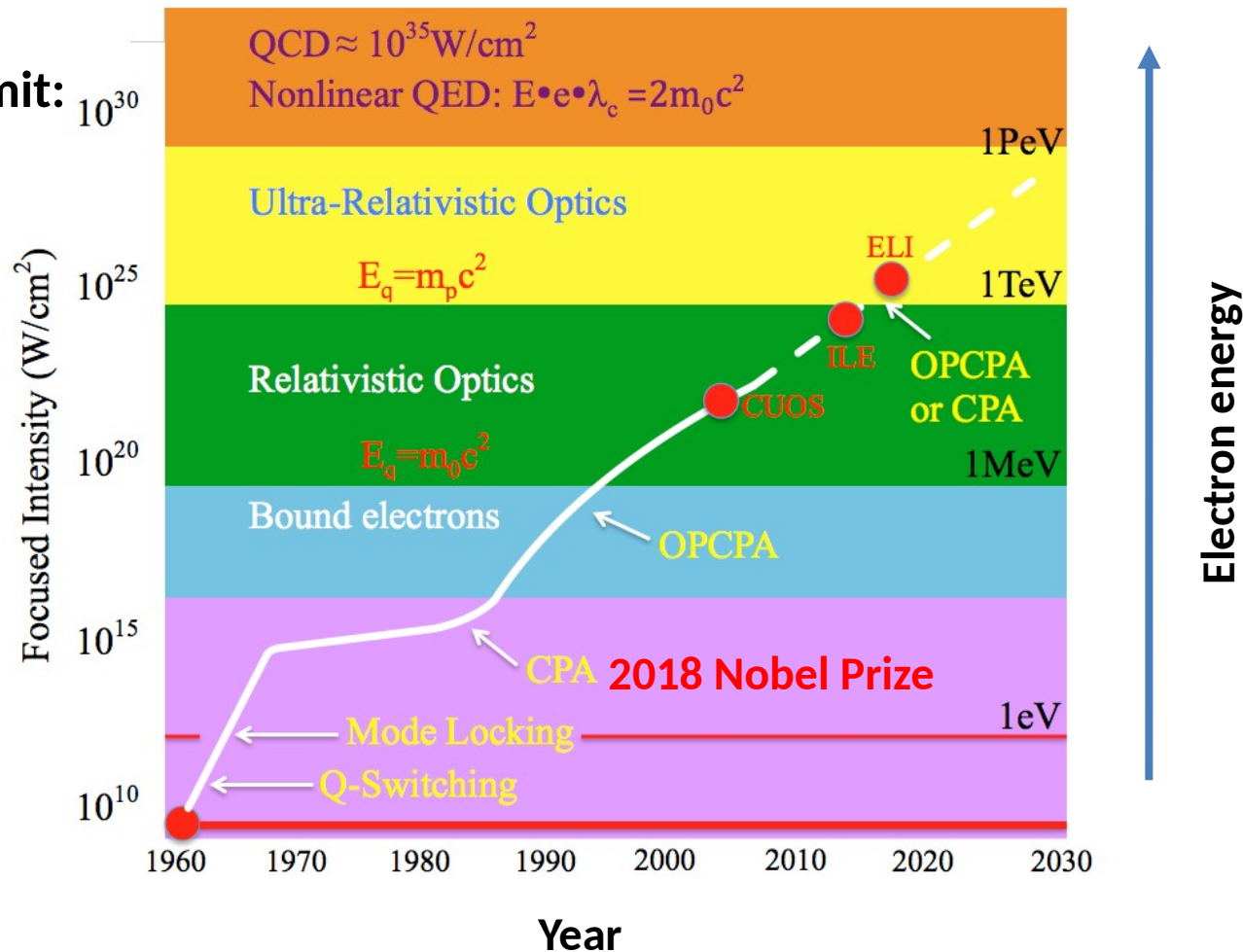
Laser diagnostics



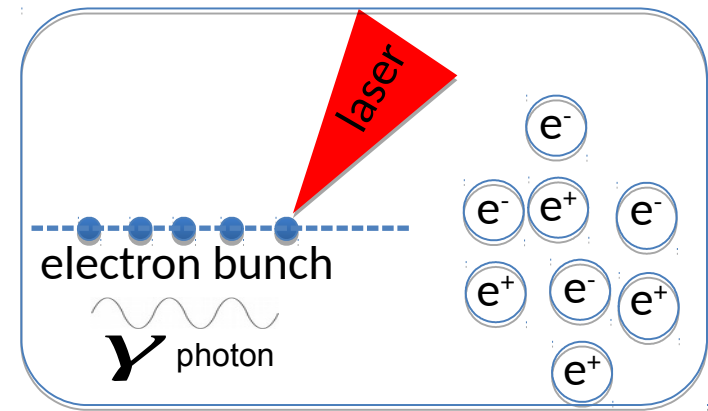
Rajendra Prasad
LUXE, DESY

- Progress in laser intensity over years

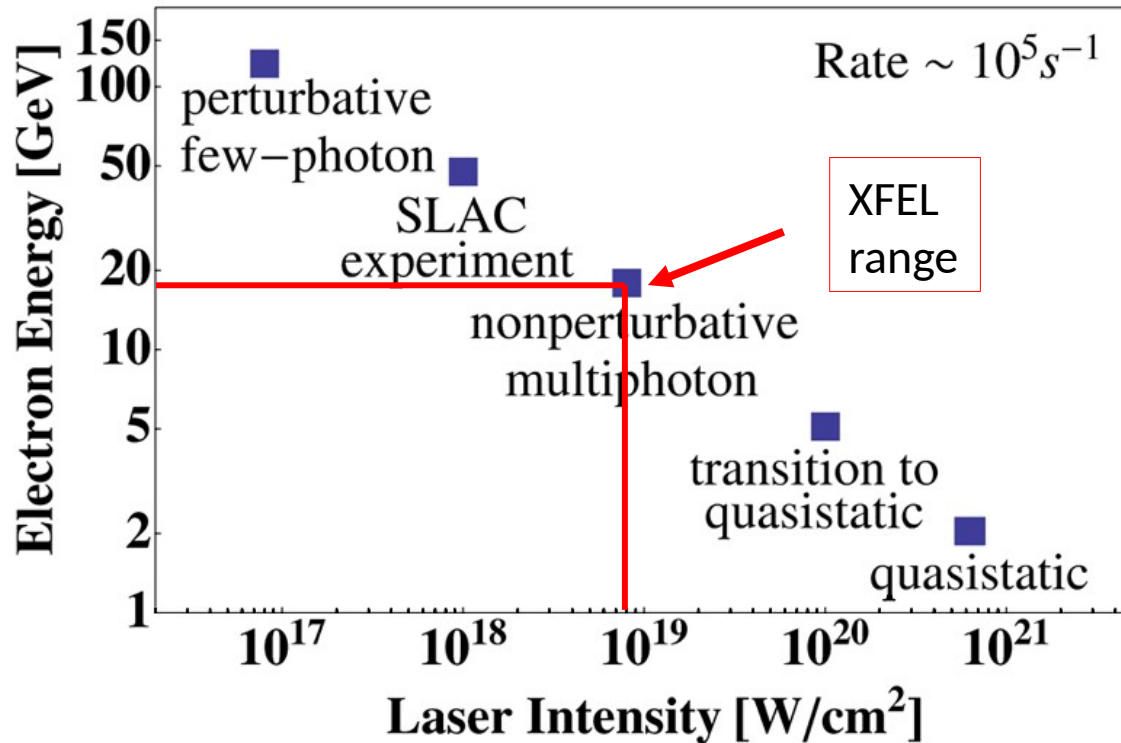
Schwinger limit:
 10^{29} W/cm^2



LUXE Project- aiming to make some ground breaking discoveries



$$a_0 = 1 \sim 10^{18} \text{ W/cm}^2$$



$a_0 \ll 1$, perturbative regime

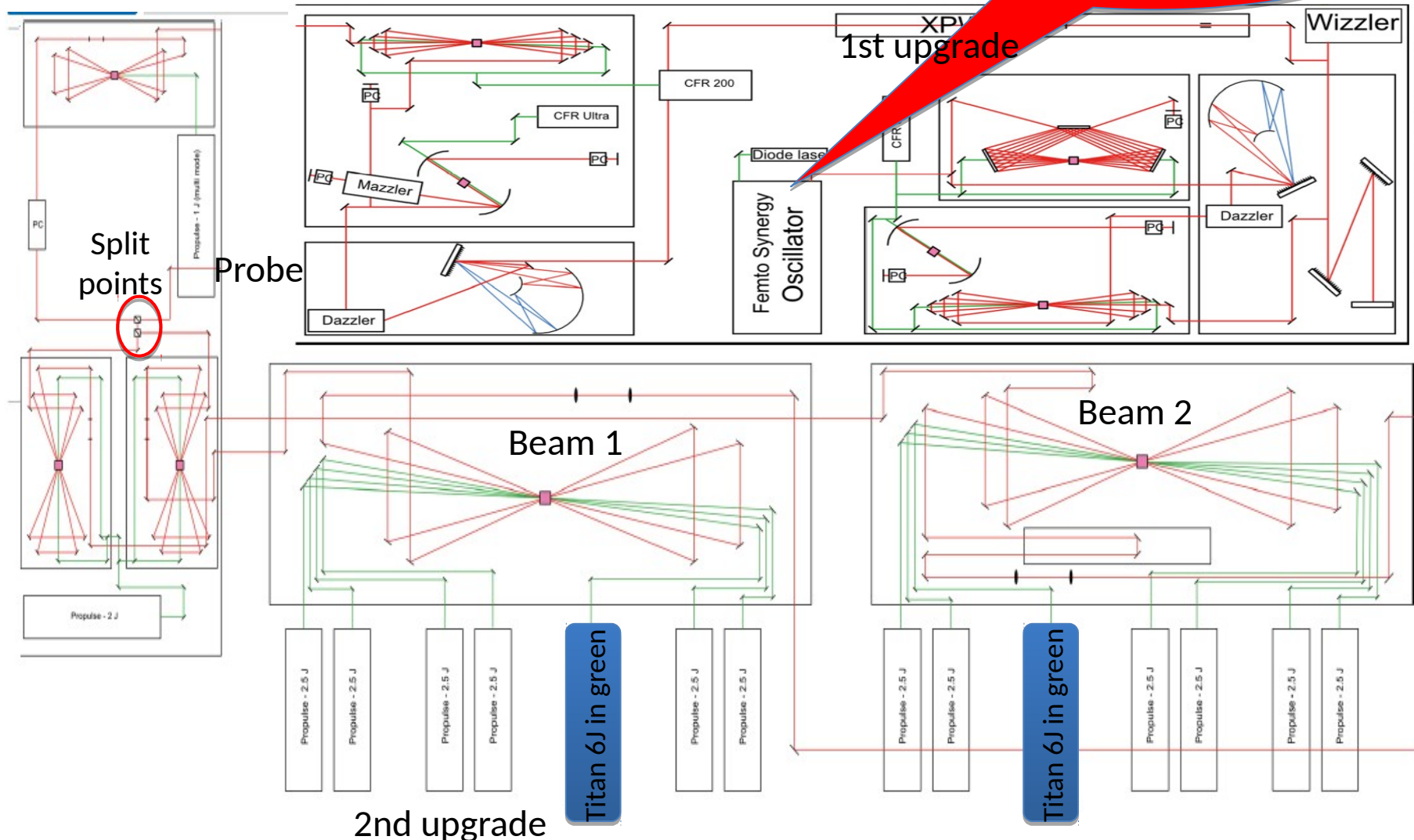
$a_0 > 1$, nonperturbative regime

- Very few experiments to test the theory in non-perturbative regime

Laser Front-end and Amplification chains

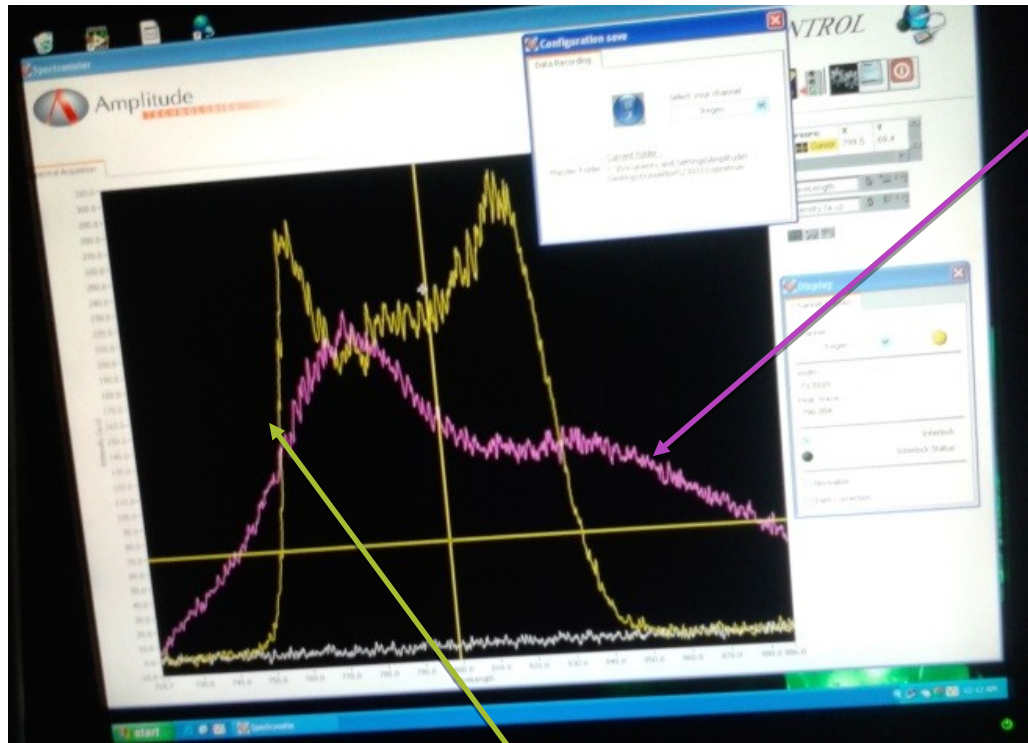
Double CPA system

Heart of laser system,
Oscillator: nJ, 100nm
bandwidth



After final amplification stage- 7J in each beam

Typical oscillator and amplified spectra



- Oscillator spectrum, >100nm bandwidth

$$\Delta\tau \propto \frac{1}{\Delta\lambda}$$

- This implies that larger the bandwidth, shorter is the pulse length!

- Spectrum after amplification-70nm,
- This is the spectrum going in the compressor

En route to amplification

- Amplification, a simplest way to gain high energy, i.e, high intensity: nJ energy level to J level: 10^9 gain in energy
- Laser beam passes through many crystals (gain medium), lenses, which have certain damage threshold.
- B integral, often used to estimate the total change in phase accumulated during passes through the medium

$$B = \frac{2\pi}{\lambda} \int n_2 I(z) dz$$

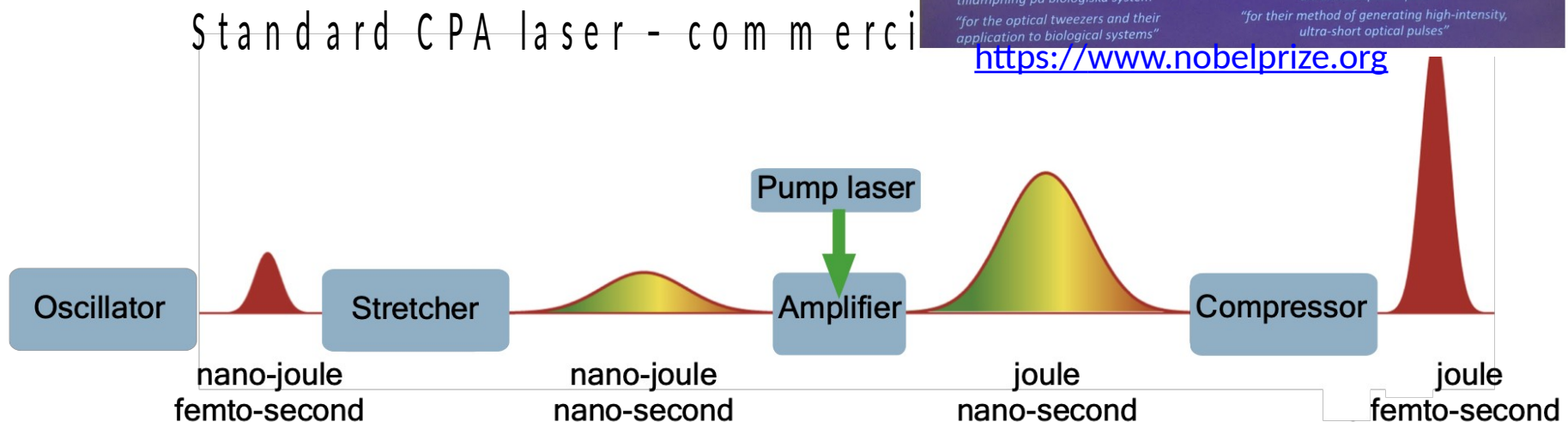
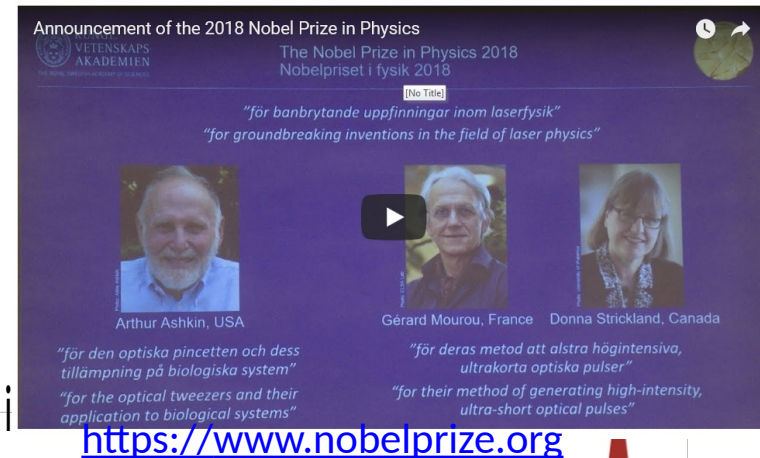
n_2 is the non linear refractive index

$I(z)$ Laser intensity

- $B < 1$ is safe.
- However, already 100s of GW/cm² intensity could be at damaging level
- As the intensity increases, B increases and can start self focusing the beam in the medium!!

Chirped pulse amplification (CPA) technique

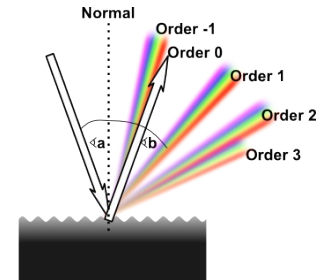
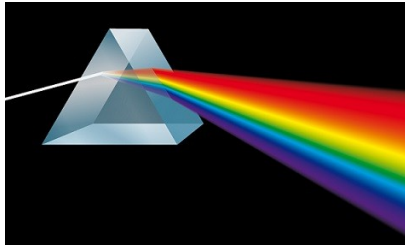
- That's why better to stretch the pulse before the amplification. That's where the CPA played vital role.
- Invented in 1985 by G Mourou et al.
- **2018 Nobel prize in physics**



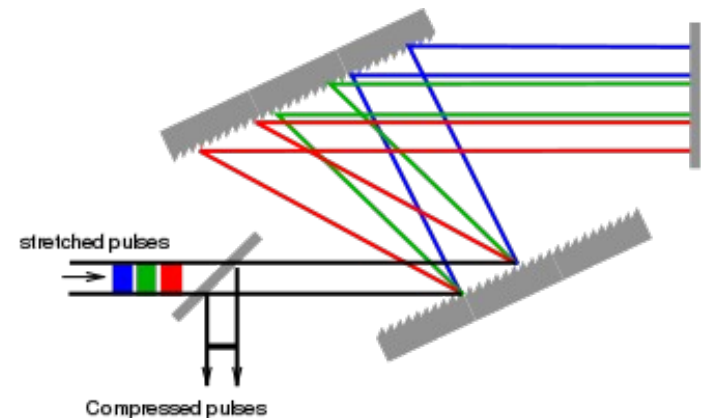
- The pulse is compressed at the very end. Need to know what is the final compressed pulse length

Stretcher and compressor

- Typical set up involves dispersive elements like prism or grating



- In the Stretcher, basic idea is to delay the frequency components (eg red and blue) with respect to each other. This is done by adjusting their optical path using geometry of the grating/prism
- Compressor is the reverse of the stretcher



Different type of diagnostics used in different laser system

For spectrum, wavefront, beam profile, energy, beam pointing, pulse duration, focus spot

$$\xi = a_0 = 0.85 \left(\frac{I \lambda_{\mu m}^2}{10^{18} W cm^{-2}} \right)^{1/2}$$

Laser
intensity

$$I = \frac{E}{\tau A}$$

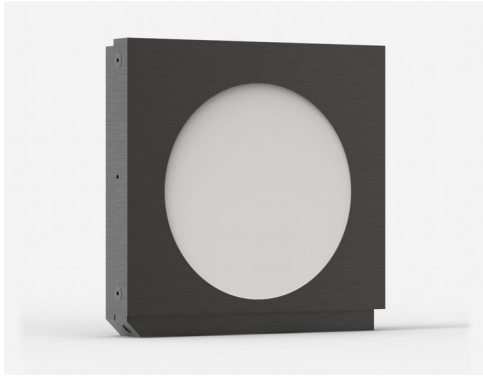
E is energy, tau- pulse duration, A as
focus spot size

● The quantum parameter $\chi \propto \gamma \cdot \sqrt{I}$

- we concentrate on intensity

Energy measurement

$$I = \frac{E}{\tau A}$$

- Energy detector from Gentec company
 - Calibrated using NIST traceable sources and proven calibration techniques
 - With calibration uncertainties of $\pm 3\%$, and repeatability better than $\pm 2\%$
 - Can work in single shot, online mode
- 
- Another method is to image the attenuated beam in high dynamic range CCD camera.
 - This as well can work in single shot, online mode and more accurately

Pulse duration measurement

$$I = \frac{E}{\tau A}$$

- **Need to measure ultra short pulses- 10^{-15} - 10^{-12} s**
- **Probably no electronic device is fast on such scale!**

There is a way

- **Classical technique- Auto-correlator, measuring the intensity over time (not the phase!)**

$$A(\tau) = \int_{-\infty}^{\infty} I(t) I(t - \tau) dt$$

- **A time dependent component of the electric pulse can be given as:**

$$E(t) = \text{Re}\{ \sqrt{I(t)} \exp(i\omega_0 t - i\varphi(t)) \},$$

$I(t)$ is the time dependent intensity and $\Phi(t)$ is the phase

- **Phase info is needed to correct any higher order dispersion from dispersive elements, eg, grating in the compressor**

What to do to get the phase and intensity both?

- One can get the phase information from the spectrum
- Spectrally resolved autocorrelator signal gives a spectrogram:

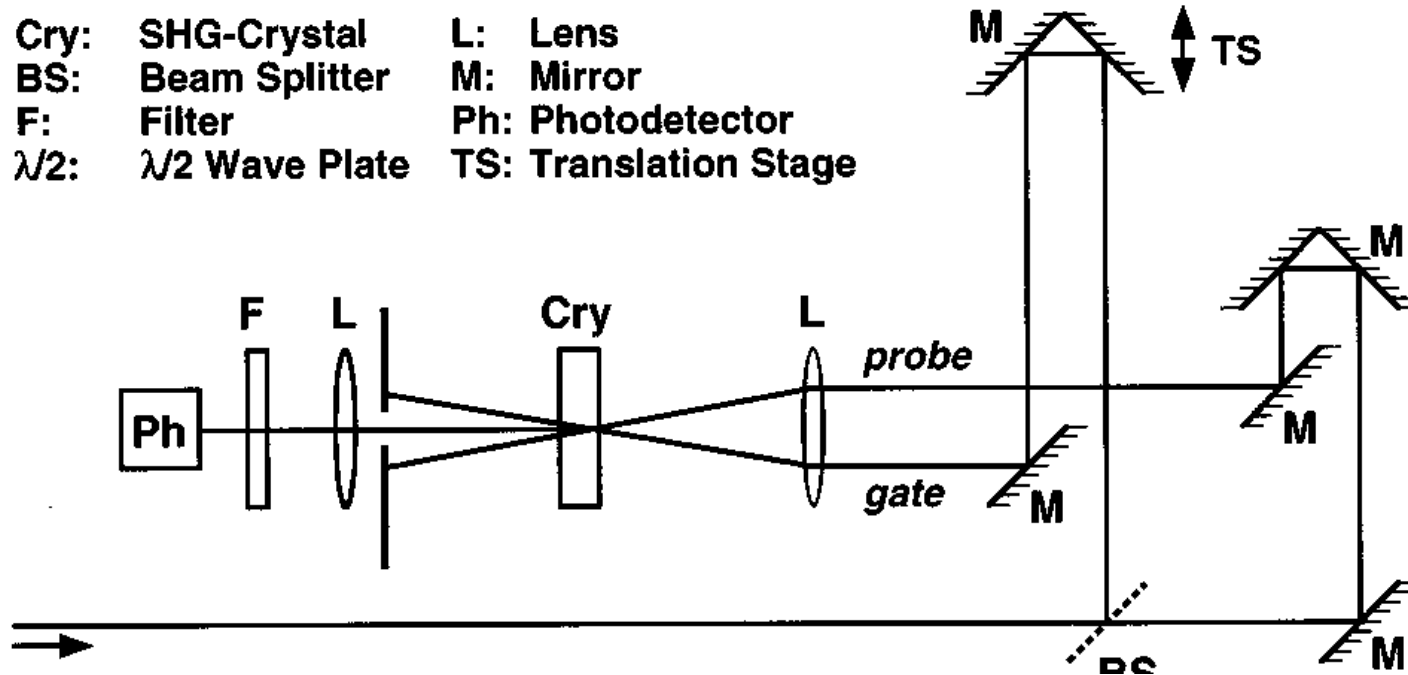
$$I^{SHG}(\omega, \tau) = \left| \int_{-\infty}^{\infty} E(t) E(t - \tau) \exp(-i\omega t) dt \right|^2$$

Here tau is the relative delay between two pulses

- Gate the pulse by itself which is the shortest event. This avoids any artificial/residual signal in the main pulse
- A nonlinear crystal such as CaF_2 can be used to help the gating work

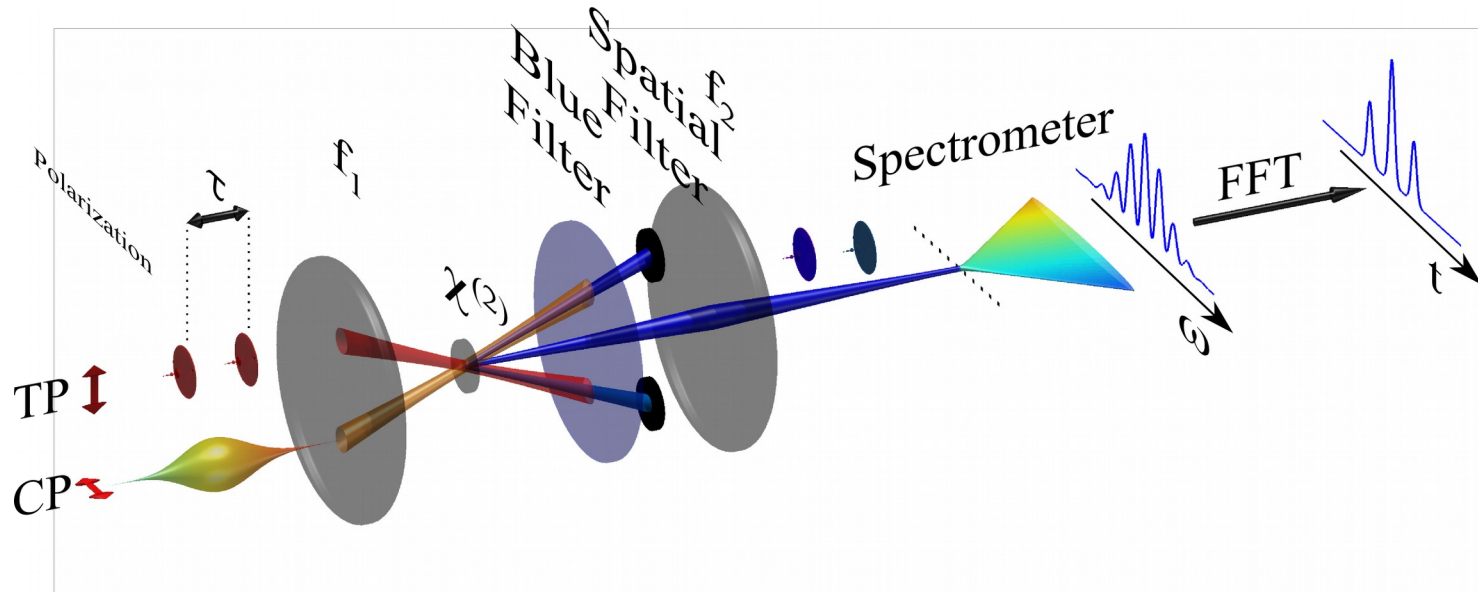
Frequency resolved optical gating (FROG)

Cry: SHG-Crystal L: Lens
BS: Beam Splitter M: Mirror
F: Filter Ph: Photodetector
 $\lambda/2$: $\lambda/2$ Wave Plate TS: Translation Stage



- Can work in single, multi shot mode
- Easy to use
- 1-2% accuracy

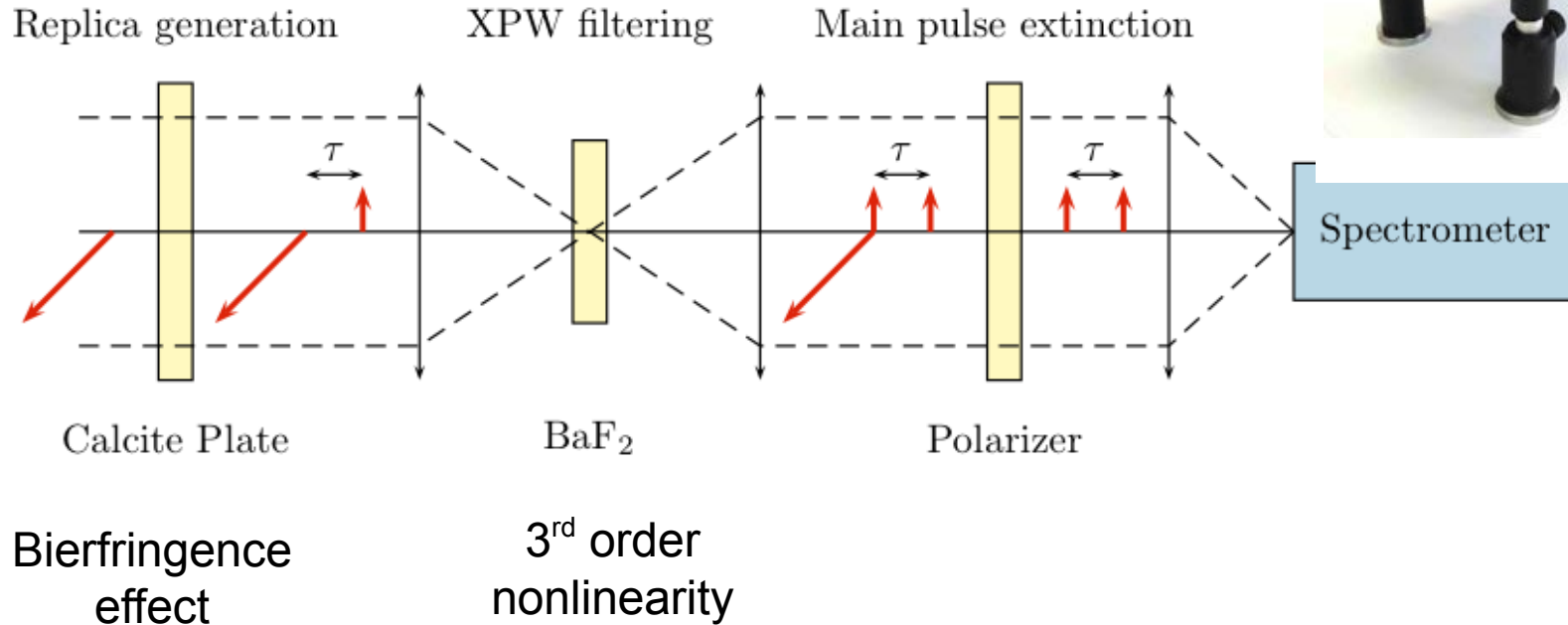
Spectral phase interferometry for direct electric-field reconstruction- SPIDER



- Works on the gating principle, however, does not need time delay stage
- 1-2% accuracy
- More accurate compare to FROG as does not need iterative algorithm

Wizzler- Fastlite

Self-Referenced Spectral Interferometry



- **In this case even split beam is not needed.**

WIZZLER

Femtosecond pulse measurement device

Standard Models



Highest dynamic range

Single shot, single beam

Extreme ease of use

Calibration-free

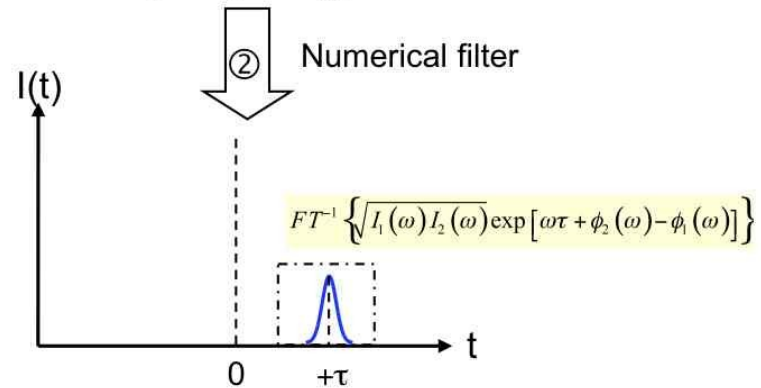
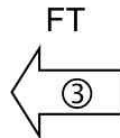
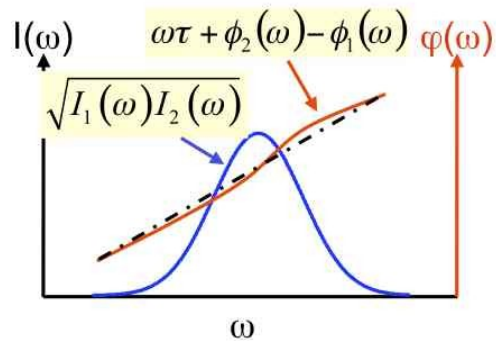
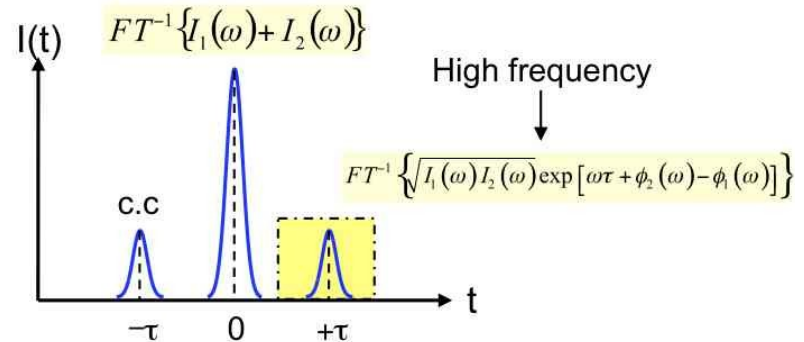
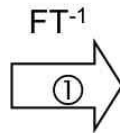
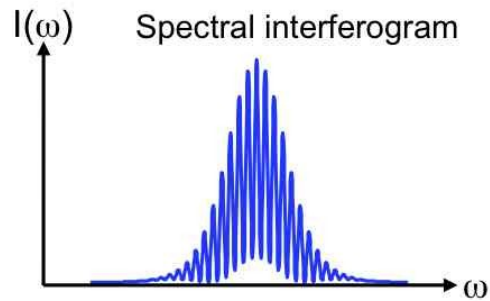
Direct retrieval algorithm

Data logging

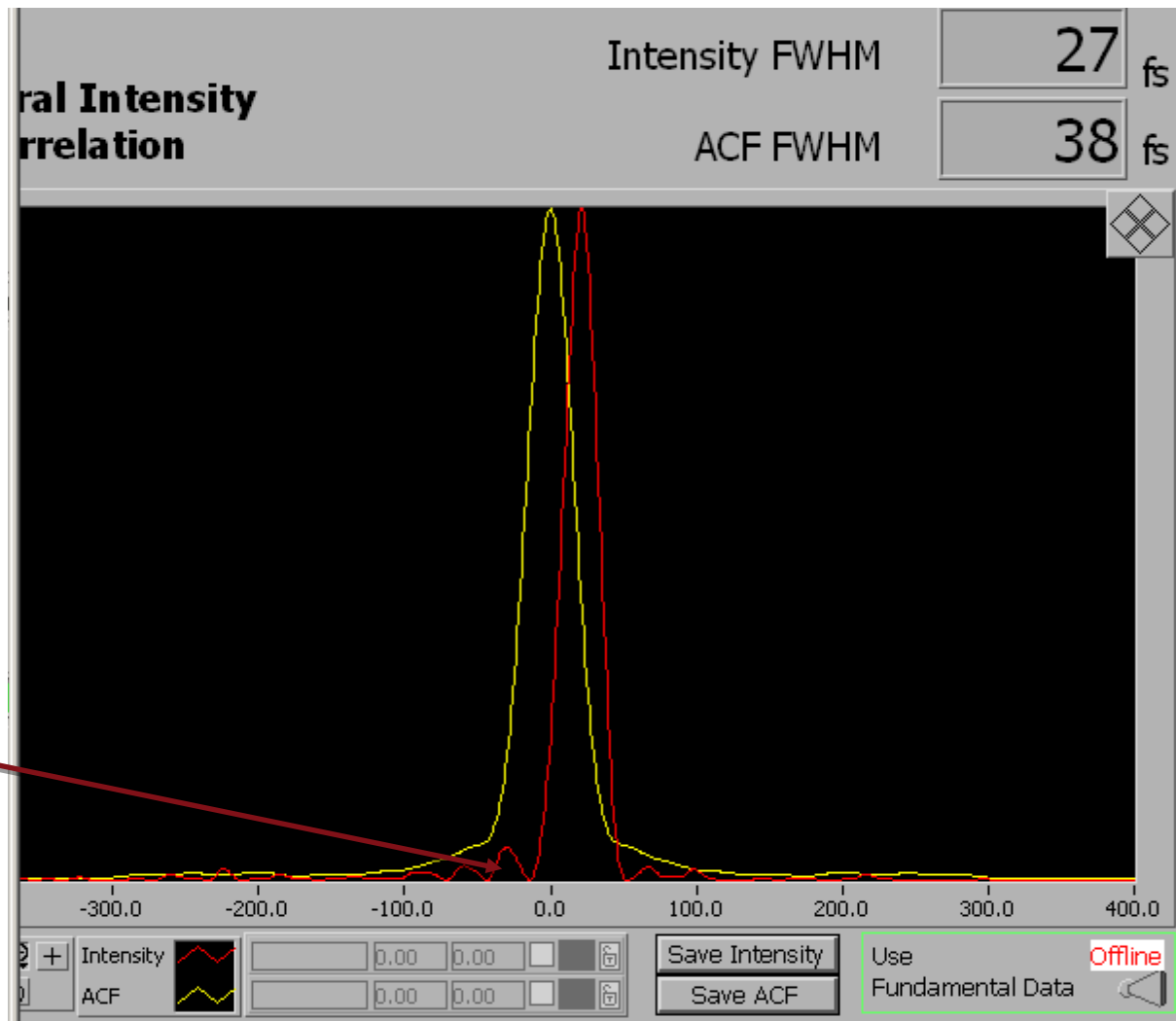
Vacuum-compatible option

Pulse compression optimization
for Dazzler users

Fourier-transformed spectral interferometry



Spider trace example

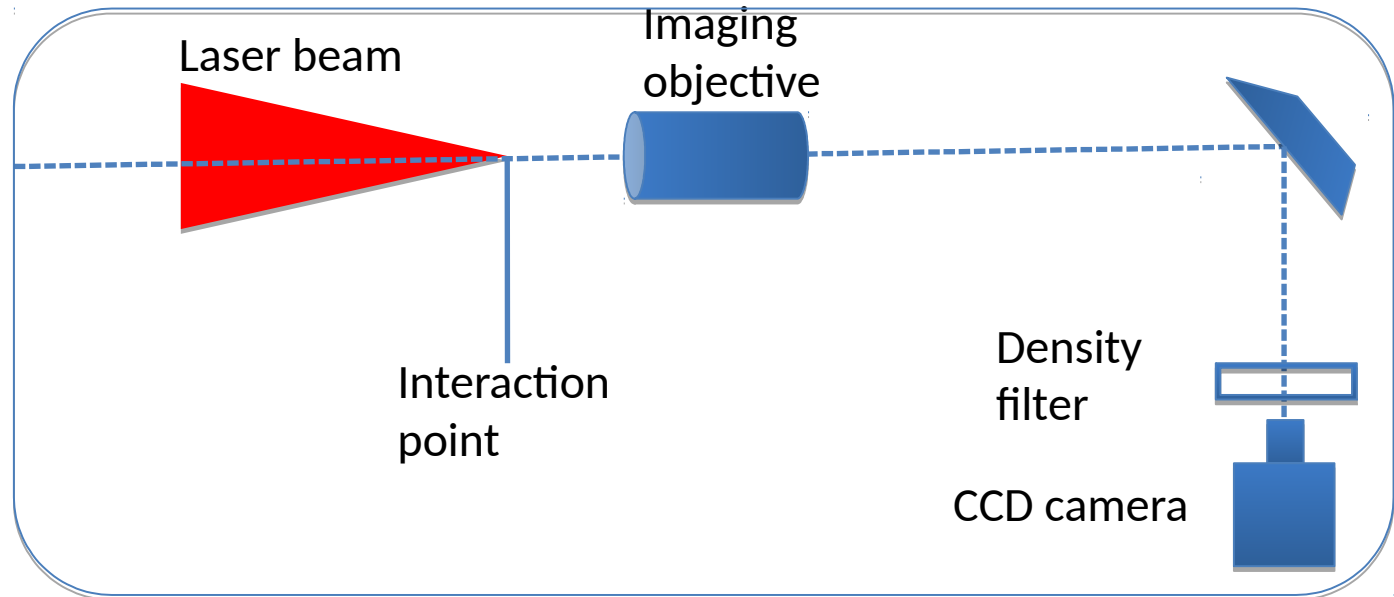


One can compensate using other device so called DAZZLER

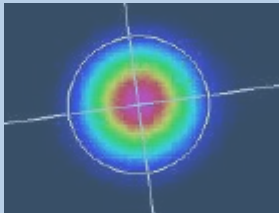
Focus diagnostics

$$I = \frac{E}{\tau A}$$

Typical setup

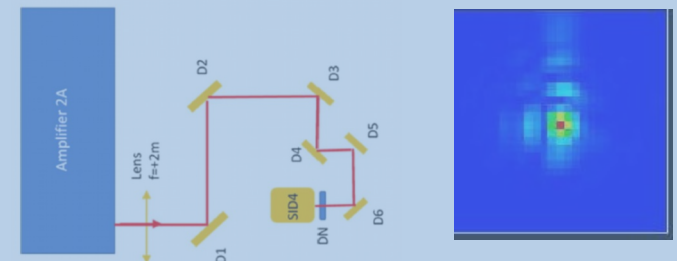


Low energy method



By reducing the energy in the pulse, eg, switching of pump laser

High energy method



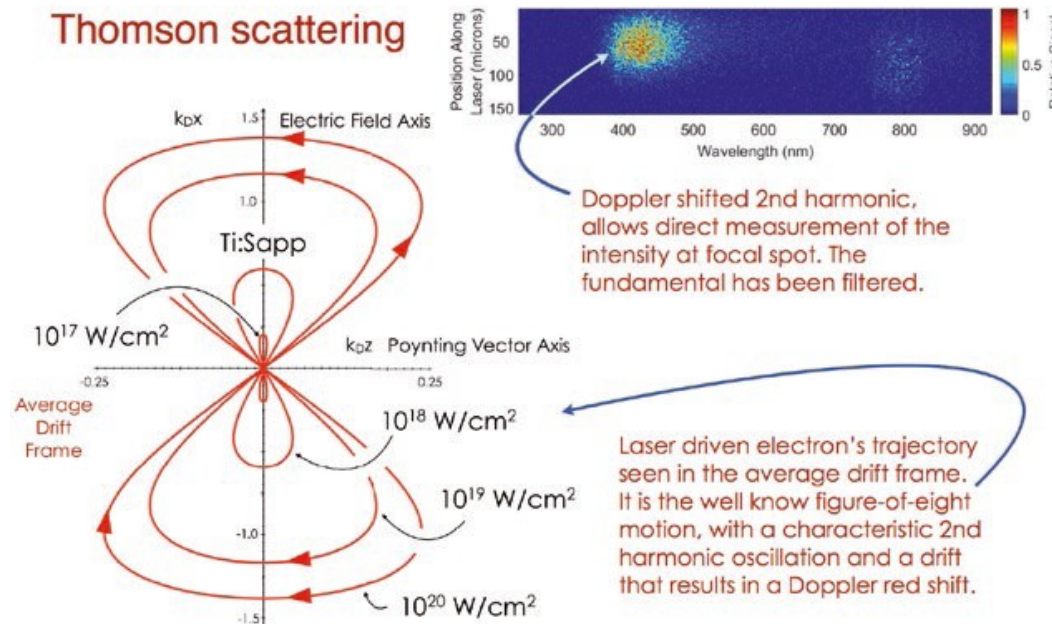
Can one simply measure the intensity?

$$I = \frac{E}{\tau A}$$

- Intensity as a function of the observed nth harmonic wavelength

$$I(\lambda^{(n)}, \theta; n) = \frac{2\pi m_e c^3}{r_0 \lambda_0^2 (1 - \cos \theta)} \left(\frac{n \lambda^{(n)}}{\lambda_0} - 1 \right), \quad (1)$$

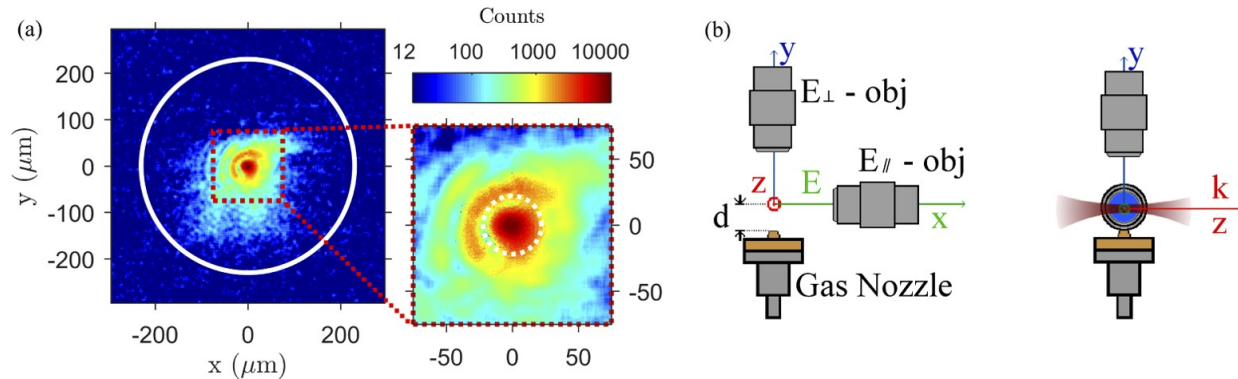
where λ_0 , θ , m_e , r_0 and c are the laser wavelength, the polar angle relative to $\vec{k}$, the electron mass, the classical electron radius and the vacuum light speed respectively.



Electron dynamics in electromagnetic field: famous Figure of eight

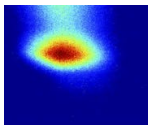
Experimental set up at Salamanca Pulsed Lasers Center- Spain

Low intensity measurement- via focus

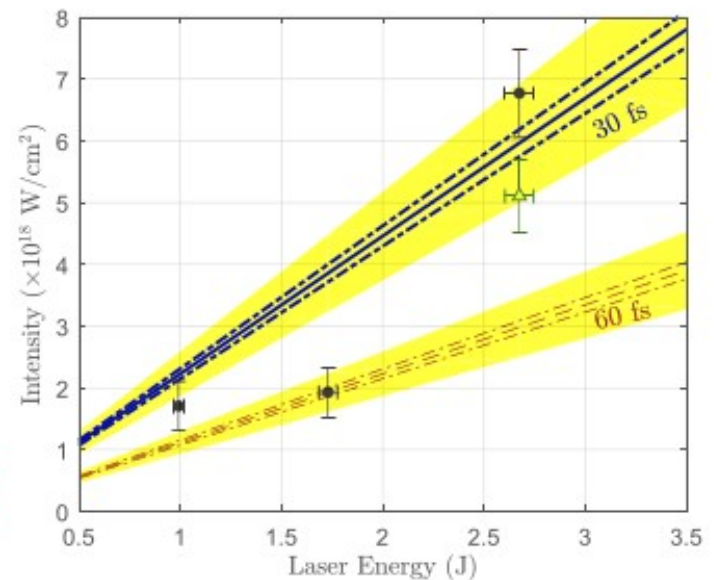
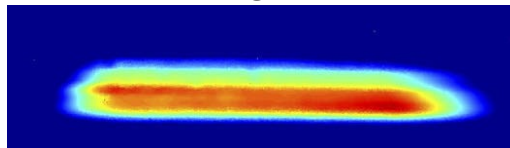


High intensity measurement via Thomson scattering

along y axis



along x axis



Other indirect methods for intensity measurement

- Characterizing extreme laser intensities by **ponderomotive acceleration** of protons from rarified gas- “proposed”
 - Density limit $<10^{16}/\text{cm}^3$
 - Experimental challenges- detection sensitivity etc
- Precise in-situ measurement of laser pulse intensity using **strong field ionization**
 - Suitable for low energy (low intensity range)
- Compton edge shift -scattered photon energy scaling $1/\sqrt{1+\xi^2}$

Summary

- **There are various possible way to diagnose the laser parameters.**
- **Different direct and indirect methods for intensity measurement need to be tested**

**Thanks for your kind
attention**